



Docket No.: 060188-0861

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Apprization of

Satoshi TAMURA, et al.

Application No.: 10/849,823

Filed: May 21, 2004

For: METHOD FOR FABRICATING SEMICONDUCTOR DEVICES

: Customer Number: 53080

: Confirmation Number: 8403

: Group Art Unit: 2891

: Examiner: Matthew L. Reames

AMENDMENT

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Final Office Action dated November 2, 2006, having a shortened statutory period for response set to expire February 2, 2007, please amend the above identified application as follows: